

INFORMATION DISCLOSURE CITATION	Applicant: Takahiro NIWA et al. Ser.No. : 10/808 967 Filed : March 25, 2004 Conf. No.: 7073 Atty.Ref.: N&H 446 Group : 3683
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SEP 21 2004

Examiner Initial*	Document Number	U.S. PATENT DOCUMENTS			Class	Sub Class	Filing Date
		Date	Name				
XLN	AA 3 162 271	12/22/1964	HANSON				
	AB 5 416 962	05/23/1995	PASSARELLA				
↓	AC 5 518 088	05/21/1996	BROSILOW				
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation	
					Yes	No
XLN AL 1 498 007 ✓	01/18/1978	UNITED KINGDOM	English Language Document			
AM 38 39 477 ✓	05/31/1990	GERMANY	English Abstract Attached			
AN 5-231452 ✓	09/07/1993	JAPAN	English Abstract Attached			
↓ AO 0 734 853 ✓	10/02/1996	EUROPE	English Language Document			
AP						

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

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EXAMINER	<i>Dan Negeen</i>	DATE CONSIDERED	6/6/05
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INFORMATION
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Applicant: Takahiro NIWA et al.
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 Group : Unknown

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U.S. PATENT DOCUMENTS

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	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
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FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation Yes	Translation No
XLN	AL 07-071519 ✓	03/17/1995	JAPAN	(English Abstract Attached)			
	AM						
	AN						
	AO						
	AP						

OTHER DOCUMENTS (Including Author, Title, Date, Pages, Etc.)

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